

Notice of References Cited	Application/Control No. 10/717,145	Applicant(s)/Patent Under Reexamination O'BRIEN, STEPHEN	
	Examiner James J. DeBrow	Art Unit 2176	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-5,517,621	05-1996	Fukui et al.	715/517
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NON-PATENT DOCUMENTS

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	U	Seehof et al;"Automated Facilities Layout Programs; ACM; 1966; pp 191-199
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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